



Time on server
Sunday Sep. 25
08 : 57 : 53

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Message from Facility Manager:

(2016-08-30 09:56:52) Your session on Tool_Charge started at 2016-08-30 09:56:36 was logged off by equipment manager
(2016-08-30 09:46:35) Your session on Tool_Charge started at 2016-08-30 09:42:18 was logged off by equipment manager
(2016-08-29 16:16:10) You forgot logoff Tool_Charge started at 2016-08-29 15:53:58.0.
(2016-08-29 16:16:10) You forgot logoff Tool_Charge started at 2016-08-29 15:53:58.0.
(2016-01-08 16:00:28) Your session on Dep - Evap, e-beam started at 2016-01-08 15:47:57 was logged off by equipment manager
(2016-01-07 14:01:37) You did not show up your reserved session on Dep - Evap, e-beam started at 2016-01-07 13:00:00
(2016-01-07 09:44:17) Your session on Dep - Evap, e-beam started at 2016-01-07 09:17:08 was logged off by equipment manager
(2015-11-06 17:29:16) Your session
[Delete all messages](#)

The tools you have been trained on are listed here. You can reserve time and use them.

Authorized Equipments (Click to view schedule)

UD Nanofabrication Facility (UDNF)

- Dep - Evap, e-beam (UD Nanofabrication Facility (UDNF)): Any Time Access, Available
- Tool_Charge (UD Nanofabrication Facility (UDNF)): Any Time Access, Available
- Tool_noCharge (UD Nanofabrication Facility (UDNF)): Equipment Manager, Available

Available Equipments (Click to request training or usage approval)

Select or type to search

Advanced Materials Characterization Lab (ACML)

Resources in this facility

Keck CAMM

Resources in this facility

Spencer Machine Shop

Resources in this facility

Test Facility

Resources in this facility

UD Nanofabrication Facility (UDNF)

Resources in this facility

- CleanRoom
- Dep - Evap, e-beam/thermal
- Dep - PECVD
- Dep - Sputterer
- Etch - Asher
- Etch - CI ICP
- Etch - F ICP
- Etch - Ion Mill
- Lith - NXQ Aligner
- Lith - Vistec EBL
- Met - 4 Point Probe
- Met - Bruker DektakXT
- Met - Ellipsometer
- Met - Zeiss SEM
- Therm - HMDS Oven
- Therm - Oven High T
- Therm - Oven Low T
- Therm - RTP

1: Click to open the drop down menu

2: Click on the tool you want to be trained on

3: Write your message to the person that manages that tool on this window. The tool manager gets an email and will contact you to arrange training.

New User Application Form

Apply to use new equipment
Etch - Asher in UD Nanofabrication Facility (UDNF)

Please tell the instrument manager your preferred time(s) for training:

Select one that best describes you: - select one -

Please read the following documents/manuals that are related to this equipment (open in separate window). You may also visit Documents link on left menu to access these documents.